



Docket No.: 060188-0660

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Toshikazu ONISHI

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

Application No.: 10/665,469

Customer No.: 20277

Filed: September 22, 2003

Confirmation No.: 5515

Group Art Unit: 2828

Examiner: Phillip Nguyen

Title: SEMICONDUCTOR LASER DEVICE AND METHOD FOR FABRICATING THE
SAME

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
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Sir:

The following Amendment and Remarks are submitted in response to the Office Action
dated September 26, 2006, pursuant to the provisions of 37 C.F.R. § 1.116.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this
paper.

Remarks begin on page 7 of this paper.